



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 10, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG825660441

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

8.24 X 5.68 X 3.48 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.04 CARAT

F

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

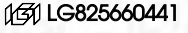
EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI LG825660441

PROPORTIONS

Medium To Slightly Thick (Faceted)

12.5%

45%

61%

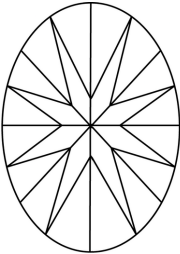
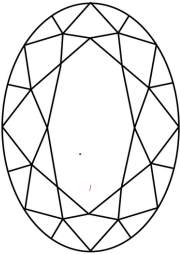
61.3%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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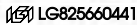
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IGI LG825660441



IGI

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OVAL BRILLIANT

8.24 X 5.68 X 3.48 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.04 CARAT

F

VVS 2

61.3%

61%

Pointed

EXCELLENT

EXCELLENT

NONE

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